


**INFORMATION  
DISCLOSURE  
STATEMENT**

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Applicant: Candelore et al.

**U.S. PATENT DOCUMENTS**

Exam. Init.	Document Number	Issue/Pub. Date	Name	Class	Filing Date

**FOREIGN PATENT DOCUMENTS**

Exam. Init.	Document Number	Date	Country	Class	Translation

**OTHER DOCUMENTS / CITATIONS**

Exam. Init.	Document
/A.C./	Chinese Office Action for corresponding application number CN 200480033305.7, dated January 8, 2010, received April 26, 2010.

Examiner: /Alfonso Castro/

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